# Laserpower Measurement Tutorial

#### Instrument & measuring mode

- Use Powermeter PT 9610
- Primary switch on is at the top side of device (On/Off-slider)
  → After use you always have to switch off the primary switch in order to avoid a shift in instruments precision!
- Secondary switch on at the bottom of control panel (On/Offpushbuttons)
- Measure in RMS L Mode X
- Set mode by using buttons: **RMS** and **HF/LF/WB**
- Record the upper value in the spreadsheet
- The measuring field on the detector head is the white spot, try to center the beam in it

#### General

Always use the same 10x objective (yellow ring, NA=0.3) for measurement. Lasers should be switched on at least 1 hour before measuring to warm up. Set the argon laser emission to approx. 30% for warming up. For measuring boost emission up to 100% (especially important for the argon laser).

Adjust the detector head with a weak laserline (like 458nm) with approx. 30-50% emission. The measuring field is the white spot on the head.

Don't forget to switch the different wavelengths on power meter, too (arrow keys). **Avoid outside light sources** because they will falsify the measurements. Record the values when they are stable.

Measurements are to be recorded in the spreadsheet of the particular microscope. URL:

docs.google.com

## Measurements at OLYMPUS FV 1000 Confocal

- 1 hour before measurement
  - To start system according to start routine switch on the power supply unit below the monitors
    - ⇒ Therefore first push the black button (left side) and then switch on the several red buttons
  - 405nm-tube switch-on is on power supply unit: continuous "LD405" & pulsed laser "405nm CUTTER"

Switch on laser-units (left rack):

- 561nm-tube on top position
  - ⇒ Turn key to "1" position for power supply → green "power on" control light turns on
  - ⇒ Push green button "laser on" → yellow "laser emission" control lights turn on
- 633nm-tube on middle position
  - $\Rightarrow$  Switch key to "1"
- Argon-tube on bottom position
  - $\Rightarrow$  1<sup>st</sup> switch button to "1" for power supply and fan function
  - $\Rightarrow$  2<sup>nd</sup> turn key to "1" for laser emission
  - $\Rightarrow$  3<sup>rd</sup> maximize emission by turning the controller wheel to the right until it stops

Directly before measurement

 After boot up start the Olympus FV10-ASW 1.7 Software and enter for userID: "Maker" and for Password: "Access"



Microscope settings

- Take out the DIC-slider and push in magnification slider in for 1x both below objective revolver on right micro side
- Open shutter by shifting from white-filled to non-filled circle (on right revolver side)
- Push "ESC" next to focus wheel to get objectives to bottom position

Detector head

- Place detector head with measuring field downwards on dish holder
- While maximizing the first laser emission (later in procedure) center the beam in scan field (you can see the spot from left lower side)
- For this use a low wavelength with approx 50% emission

### Software settings

- Choose menu → Tools → Maintenance → Index: System
  Registration for the FV 1000 Setup window (Figure A)
- Change the three buttons on right side to **Blanking Off**
- Save and close and click OK

1.7c	
RET Processing Analysis Tools	dow Help
= 22 📑 22 🕞	
×	Acquisition Control
el Slow >>	Focus x2 Focus x4 XY Repeat Lambda Depth Time
Data Select	System Registration COMB LPM Filters 1 Filters 2 Detectors Scanner Pinhole Star PI ()
System Settings	Confocal Detector Laser Combiner in
0 4:3	FV10-SPD 1 FV10-COMB V SU Normal V Blanking On
2 User Settings	FV10-OP4CH 2 FV10-LD405 V SU Normal V Blanking On
-Data Control	3 None V Normal V
0.0 0 Make Backup File	-Nencenfecal Detector 4 None V Normal V
	None 5 EV10-1 D405 V ASU Normal V Blanking On
File >> HW ROM	None 6 None y Normal y
0 um 0 HW ROM >>	
Setting file	Transmitted Detector
Restore Default	FV10-TD
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35	
t0	Save and Close Close Save to ROM and File
.83 <u>↓</u> 15.05um Go	€ Acavatum → imagestam Wait Time

Figure A) FV 1000 Setup window

- Choose the LightPath & Dyes button in Image Acquisition Control window (Figure B)
- Choose beam splitter BS20/80 in Excitation DM field in the LightPath & Dyes window (Figure C)
- Set Sim light path button to OFF in Image Acquisition Control window (Figure B) for None in the light path in LightPath & Dyes window



#### Figure B) LightPath & Dyes button



#### Figure C) LightPath & Dyes window

- Click X/Y-Repeat in Image Acquisition Control window to scan one field (will appear on right screen as black field "live fiew") then click stop
- Click the **Point** button in Acquisition Setting window and set a scan point in the center of the "live fiew" mask (Figure D)
- Choose the slowest pixel speed at the top slider of the Acquisition Setting window
- Type 32766 in the Num field in Time
  Scan menu at bottom of
  Acquisition Setting window

Measurement (Figure D)

- Push laser emission of the several wavelengths to 100% in Acquisition Setting window
- Check mark the tube you want to measure and go through the several wavelengths

Acquisition Setting	
Mode	
<< Fast 200.0us/Pixel Slow >>	
P:200.0us L:52.400	
Size	
x ◀ ─ ▶ 256 by 256 ▼	
Area Zoom	
· · · · · · · · · · · · · · · · · · ·	
Laser	
□ 458 <b>■</b> 100.0 %	
□ 488 <b>■</b> 100.0 %	
□ 515 <b>■</b> 100.0 %	
LambdaScan	
Start SUU IIII EIN SZU IIII	
StepSize 5 nm Num 3	
Band Width 📃 10 nm 🔎	
Microscope	
UPLSAPO 60X O NA:1.35	
Set 0.10 → um Go	
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Set 0 Start End Slices 3	
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X:0 147um Y:0 147un	
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Figure D) Acquisition Setting window

### 405 Cutter Measurement

- Choose Stimulus Setting button in Image Acquisition Control window (Figure E)
- Set Sim light path button to ON in Image Acquisition Control window (Figure B) for ADM450 in the light path in LightPath & Dyes window



Figure E) Stimulus Setting window

#### Stimulus Setting window (Figure E)

- Choose SIM in UseScanner menu and Manual in Stimulate Start Setting
- Choose the slowest pixel speed in Mode menu
- Change scan Mode in Acquisition Setting menu to Normal
  = full scanfield (Figure E)

- Change scan Mode in Stimulus Setting window to Point and set a scan point in the black scan field center on popup Reference Live window
- Check mark the **405** laser and push laser **emission** to 100%
- Make sure power is turned up fully at controller

After measurement – shutting down routine

- Choose menu → Tools → Maintenance → Index: System
  Registration for the FV 1000 Setup window
- Change the three buttons on right side to **Blanking On**
- Save to ROM and file and click OK in popup menu + Save and close and click OK twice in popup menus
- Close program and don't save anything

If any user is following

- log off windows account
- just turn down the Argon-tube emission on bottom laser controller
  - $\Rightarrow$  1<sup>st</sup> minimize emission by turning the controller wheel to the left until it stops and then a half turn to the right

If no user is following

- Switch off the computer
- Switch off the power supply unit below the monitors
  - ⇒ Therefore first switch off the red buttons then push the black button (left side)

Switch off laser-units (left rack):

- **561nm-tube** top most controller
  - ⇒ Push red button "laser off" → yellow "laser emission" control lights turn off
  - ⇒ Turn key to "0" position → green "power on" control light turns off
- 633nm-tube middle controller
  - $\Rightarrow$  Switch key to "0"
- Argon-tube bottom most controller
  - $\Rightarrow$  1<sup>st</sup> minimize emission by turning the controller wheel to the left until it stops and then two turns to the right
  - $\Rightarrow$  2<sup>nd</sup> turn key to "0" for laser emission
  - $\Rightarrow$  3<sup>rd</sup> after cooling switched off, switch button to "0"